### PATENT APPLICATION

## IN THE UNITED STATES PATENT AND TRADEMARK OFFICE

In re application of Docket No: Q77321

Hiroshi OKUMURA

Appln. No.: 10/773,333 Group Art Unit: 3663

Confirmation No.: 8920 Examiner: Johannes P. MONDT

Filed: February 9, 2004

For: THIN FILM TRANSISTOR SUBSTRATE AND METHOD OF MANUFACTURING THE SAME

# AMENDMENT UNDER 37 C.F.R. § 1.111

#### MAIL STOP AMENDMENT

Commissioner for Patents

P.O. Box 1450

Alexandria, VA 22313-1450

Sir:

In response to the Office Action dated August 21, 2008, please amend the aboveidentified application as follows on the accompanying pages.

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